Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/617,172	KIM ET AL.	
Examiner	Art Unit	
Tianjie Chen	2656	

SEARCHED					
Class	Subclass	Date	Examiner		
Updated		2/2/2006	TJ		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

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